

PM2024 - 16th Pisa Meeting on Advanced Detectors

Tuesday, 28 May 2024

Applications to Industrial and Societal Challenges - Oral session - Sala Maria Luisa (15:30 - 16:10)

-Conveners: Peter Dendooven; Anna Mazzinghi

time	[id] title	presenter
15:30	[439] Development of a sapphire microstrip detector for gamma beam monitoring	GRUTTA, Pietro
15:50	[298] 2D and 3D analysis improvements with Machine Learning for Muography Applications	LEFEVRE, Baptiste